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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Shunichi SEKI et al.

Group Art Unit: 2811

Application No.: 10/613,081

Filed: July 7, 2003

Docket No.: 116462

For: COMPOSITION, ORGANIC CONDUCTIVE LAYER INCLUDING COMPOSITION, METHOD FOR MANUFACTURING ORGANIC CONDUCTIVE LAYERS, ORGANIC EL ELEMENT INCLUDING ORGANIC CONDUCTIVE LAYER, METHOD FOR MANUFACTURING ORGANIC EL ELEMENTS, SEMICONDUCTOR ELEMENT INCLUDING ORGANIC CONDUCTIVE LAYER, METHOD FOR MANUFACTURING SEMICONDUCTOR ELEMENTS, ELECTRONIC DEVICE, AND ELECTRONIC APPARATUS

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- 2. Each item of information contained in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart application, and this communication was not received by any individual designated in §1.56(c) more than thirty days prior to the filing of this Information Disclosure Statement.
- 3. The references were cited in a counterpart foreign application.
- 4. In accordance with 37 CFR §1.98(a)(2)(ii), copies of any U.S. patents and patent application publications are not attached.

5. A computer-generated English language translation of the following Japanese reference has been obtained from the website of the Japanese Patent Office ([http://www.jpo.go.jp]), and is attached, but has not been reviewed for accuracy. See Reference 2.

Respectfully submitted,



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Date: January 31, 2005

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